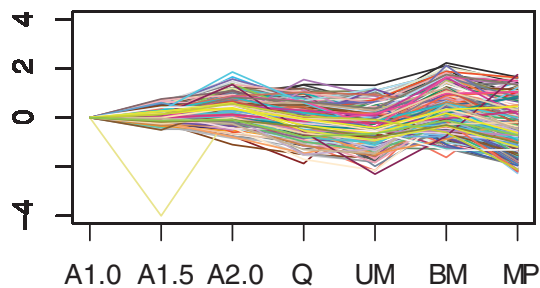
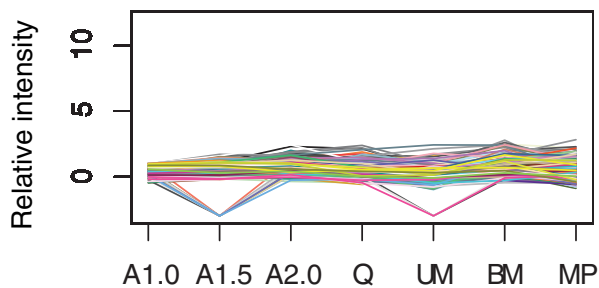


Relative intensity (1mm as reference)

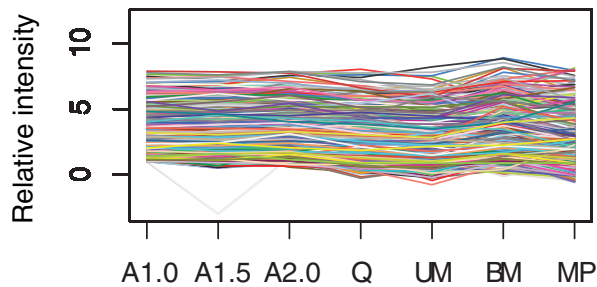
(a) Constitutive pattern



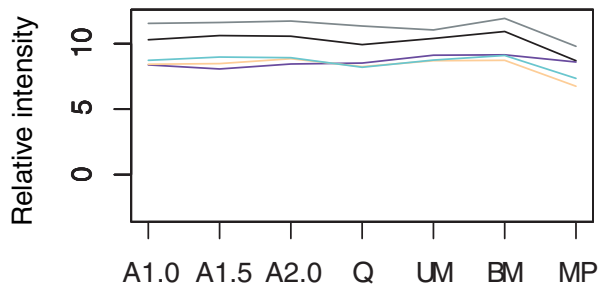
(b) Constitutive low N=883



(c) Constitutive medium N=1880

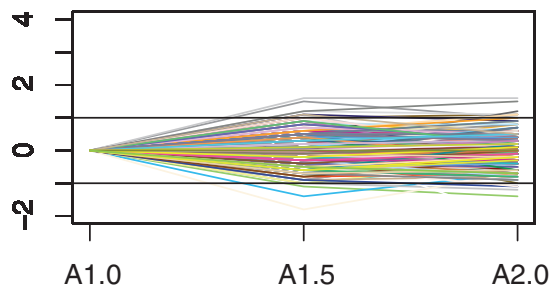


(d) Constitutive high N=5



Relative intensity (1mm as reference)

(e) 22K intensities pattern



(f) 22K intensities for constitutive probes

